

Electronic Patent Application Fee Transmittal

Application Number:	10019407			
Filing Date:	25-Mar-2002			
Title of Invention:	Polysilicon semiconductor thin film substrate, method for producing the same, semiconductor device, and electronic device			
First Named Inventor/Applicant Name:	Yoshinobu Kimura			
Filer:	Larry Naoum Anagnos/Donna Heise			
Attorney Docket Number:	520.41003 X00			
Filed as Large Entity				
U.S. National Stage under 35 USC 371 Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Notice of appeal	1401	1	510	510
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Extension - 2 months with \$0 paid	1252	1	460	460
Miscellaneous:				
Total in USD (\$)				970